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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application Serial No..... 10/620,468  
 Filing Date ..... July 15, 2003  
 Inventor ..... Dinesh Chopra  
 Assignee ..... Micron Technology, Inc.  
 Group Art Unit ..... 2822  
 Examiner ..... T. Tran  
 Attorney's Docket No. .... MI22-2345  
 Title: Conductive Connection Forming Methods, Oxidation Reducing Methods,  
 and Integrated Circuits Formed Thereby

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

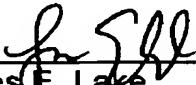
The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449. No admission is made regarding whether the submitted reference is prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Dated: 22 Jun 2005

By:

  
 James E. Lake  
 Reg. No. 44,854

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Sheet 1 of 1

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2345	SERIAL NO. 10/620,468		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)		APPLICANT: Dinesh Chopra					
		FILING DATE July 15, 2003		GROUP 2822			
<b>U.S. PATENT DOCUMENTS</b>							
*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
AA		6,172,421	01/2001	Besser et al.	257	751	
AB		6,444,567	09/2002	Besser	438	625	
AC							
AD							
AE							
AF							
AG							
AH							
AI							
<b>FOREIGN PATENT DOCUMENTS</b>							
		Document Number	Date	Country	Class	Subclass	Translation
	AJ						Yes
	AK						No
	AL						
<b>OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)</b>							
	AM						
	AN						
	AO						
EXAMINER		DATE CONSIDERED					
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>							